

Form PTO-1449 (Modified)

Atty. Docket No.  
74/113Application No.  
10/017,932

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION  
(USE SEVERAL SHEETS IF NECESSARY)

Applicant:  
Hasman et alFiling Date:  
18 December 2001Group/Art Unit:  
2872

## U.S. PATENT DOCUMENTS

	EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
AA							
AB							
AC							

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
							YES	NO
AI								
AJ								

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AM	RA	Bahram Javidi and Takanori Nomura, "Polarization encoding for optical security systems", <i>Optical Engineering</i> vol. 39 no. 9 pp. 2439-2443 (2000),.						
AN	RA	N. Davidson et al., "Realization of perfect shuffle and inverse perfect shuffle transforms with holographic elements", <i>Applied Optics</i> vol. 31 no. 11 pp. 1810-1812 (1992),						
AO	RA	Uwe D. Zeitner et al., "Polarization multiplexing of diffractive elements with metal-stripe grating pixels", <i>Applied Optics</i> vol. 38 no. 11 pp. 2177-2181 (1999)						
AP	RA	Gregory P. Nordin et al., "Micropolarizer array for infrared imaging polimetry", <i>Journal of the Optical Society of America</i> vol. 16 no. 5 pp. 1168-1174 (1999)						
	RA	Franco Gori, "Measuring Stokes parameters by means of a polarization grating", <i>Optics Letters</i> vol. 24 no. 9 pp. 584-586 (1999)						
	RA	Rigorous Coupled Wave Analysis (RCWA) (M. G. Moharam and T. K. Gaylord, "Rigorous coupled-wave analysis of metallic surface-relief gratings", <i>Journal of the Optical Society of America, part A</i> vol. 3 pp. 1780-1787 (1986).						
	RA	Space-Variant polarization state manipulation with computer generated subwavelength metal stripe gratings Bomzon et al <i>Optics Communications</i> 192 (2001) 169-181						
	RA	Computer-generated space-variant polarization elements with subwavelength metal stripes, Bomzon et al <i>Optics Letters</i> Jan 2001 vol. 26						

EXAMINER

DATE CONSIDERED

5/26/04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.